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#### DOCKET NO.: 251154US2SRDX

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toru TOJO, et al.

SERIAL NO.: New Application

FILED:

Herewith

FOR:

PATTERN INSPECTION APPARATUS

#### STATEMENT OF RELEVANCY

# Reference AA (5,572,598) of Form PTO-1449:

This reference shows an optical system illuminated by a scanning laser, in which individual transmitted and reflected light and detectors are used to inspect the defects.

# Reference AB (5,563,702) of Form PTO-1449:

This reference shows an inspection method using transmitted and reflected signals from the substrate.

#### Reference AO (2002-501194) of Form PTO-1449:

This reference shows an inspection system which can detect transmitted and reflected light simultaneously.

# Reference AW of Form PTO-1449:

The cell-to-cell comparison method to obtain high defect detection sensitivity is studied in this paper. Transmission and reflection optics are used.